10/559,700

INFORMATION DISCLOSURE CITATION
(Use several sheets if necessary)

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Applicant(s) Hajime Nakazawa	IAP9 Rec'd PCT/PTO 06 DEC 2008
Filing Date --	Group Art Unit --

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		4,111,204	9-1978	Hessel			
		4,516,973	5-1985	Telang			

U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation YES	NO
		9-56810 03	1997	Japan				✔
		WO 01/49344 A1 07	2001	WIPO				✔

OTHER DOCUMENTS *(Including Author, Title, Date, Pertinent Pages, Etc.)*

ALL REFERENCES CONSIDERED EXCEPT WHERE LINED THROUGH. /AMM/

EXAMINER /Adam Marcetich/	DATE CONSIDERED 10/03/2008

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.